Experimental investigation of microtopography patterns on bacterial attachment

P.V. Rao, Deepak Patil, S Aravindan and Vivekanandan P

IIT Delhi, India

**Statement of the Problem:** The adhesion of bacterial cells on any surface is the first step of biofilm formation. Biomedical field is more concerned about biofilm formation as medical devices get frequently contaminated with bacteria and leading to the formation of mature biofilm which can put patient lives at risk. Researchers have reported that the surface topography with micro patterns affects the initial adhesion of bacterial cells. However, the effect of the number of corners on the behavior of bacterial cells is yet to be investigated. In this work, the different types of microscale geometrical features (Triangle, Square, Star pattern with four and five corners) are fabricated on polydimethylsiloxane (PDMS) using soft lithography technique (Fig. 1). Through static droplet contact angle analysis, it is confirmed that the fabricated micro patterns alter the wettability of plain PDMS surface. The effect of number of corners on the migration and initial attachment of *Escherichia coli* (*E. coli*) and *Staphylococcus aureus* (*S. aureus*) are investigated using fluorescence microscopy. The adhesion of bacterium depends on the number of corners present in the geometrical feature. Moreover, the bacterial adhesion is correlated with the ratio of pillar cross-sectional area to its perimeter (λ). The experimental investigation can be useful in designing the effective geometry which can be used in making anti-biofouling structured polymeric devices for biomedical applications.

**Recent Publications**


**Biography**

Dr. Venkateswara Rao Paruchuri is currently a Professor & Head, Department of Mechanical Engineering, Indian Institute of Technology Delhi. He received Masters & Doctorate Degrees from Indian Institute of Technology Madras. Prior to that, he obtained Bachelor’s Degree from Regional Engineering College Warangal. He has been faculty at IIT Delhi since 1996. His research interests include Material Removal Processing, Micro/Nano Manufacturing, and Sustainable Machining. He received BOYSCAST fellowship award from Government of India in 1998. He was a visiting Assistant Professor at Oklahoma State University, USA in 1999. He was visiting Professor at Tokyo Institute of Technology, Japan in 2012. He published more than 193 research papers in National and International Journals and Conferences. He supervised 21 Ph.D. and several M.Tech theses. He is also a member of Editorial Board of International Journal of Industrial Engineering: Theory, Applications & Practice. He has undertaken several sponsored research projects as Principal Investigator.

pvrao@mech.iitd.ac.in